

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant	:	Basol et al.
Appl. No.	:	10/654,542
Filed	:	September 2, 2003
For	:	CONSTANT LOW FORCE WAFER CARRIER FOR ELECTROCHEMICAL MECHANICAL PROCESSING AND CHEMICAL MECHANICAL POLISHING
Examiner	:	Morgan, Eileen P.
Group Art Unit	:	3723

RESPONSE TO OFFICE ACTION**Mail Stop Amendment**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Dear Sir:

In response to the Office Action mailed August 31, 2006, please amend the above-captioned application as set forth herein. A two-month extension of time is hereby requested.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 6 of this paper.